

1/4

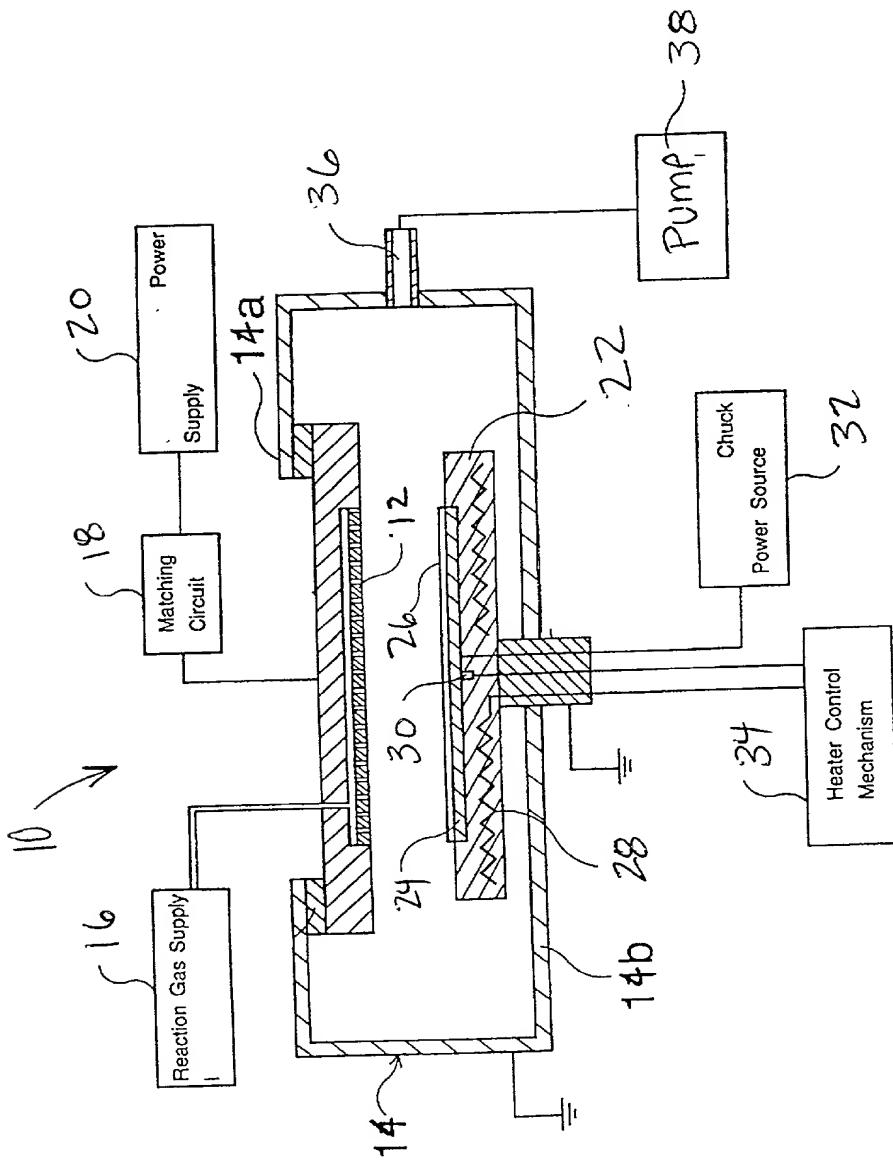


Fig. 1  
(PRIOR ART)

METHOD FOR H<sub>2</sub> RECYCLING IN  
SEMICONDUCTOR PROCESSING SYSTEM  
YOO  
DOCKET NO. M-8608 US

2/4

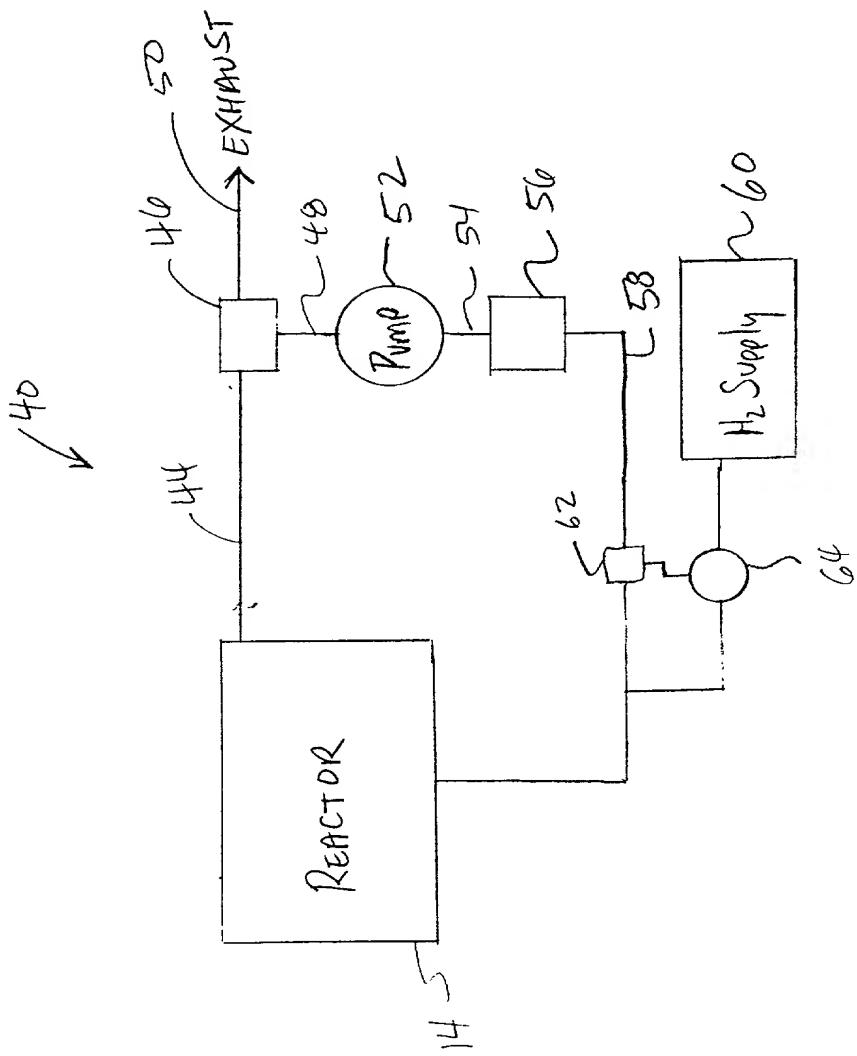


Fig - 2

METHOD FOR H<sub>2</sub> RECYCLING IN  
SEMICONDUCTOR PROCESSING SYSTEM  
YOO  
DOCKET NO. M-8608 US

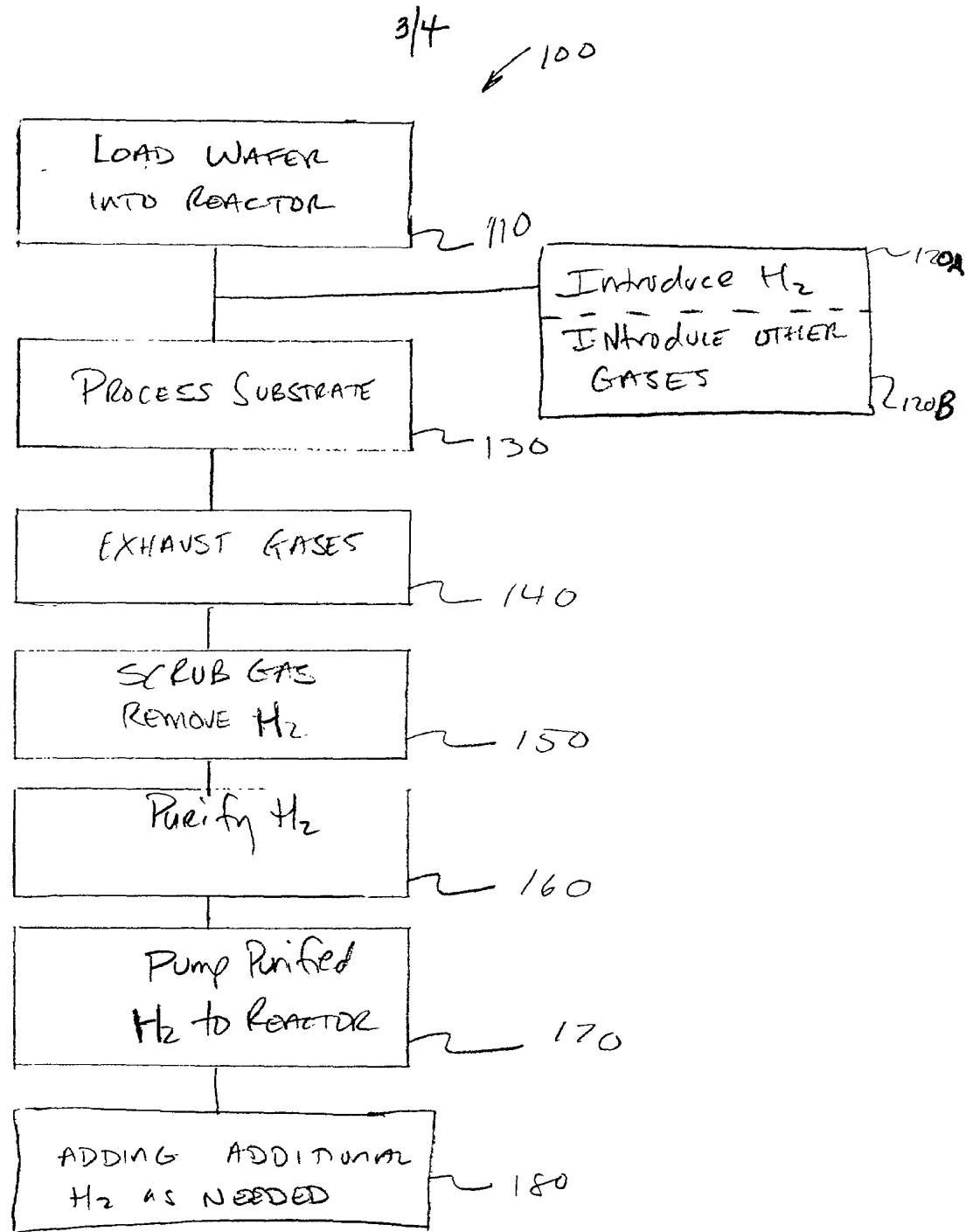


Fig-3

METHOD FOR H<sub>2</sub> RECYCLING IN  
SEMICONDUCTOR PROCESSING SYSTEM  
YOO  
DOCKET NO. M-8608 US

4/4

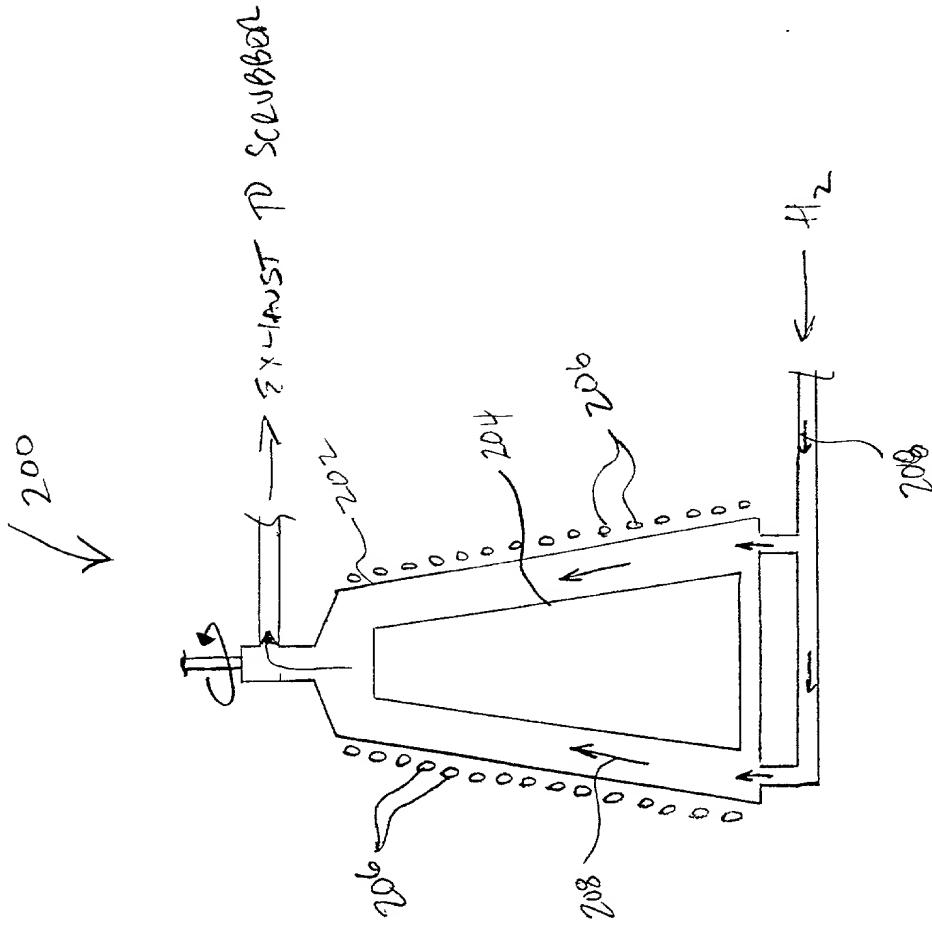


Fig - 4